

Photograph No.1 Setup for spurious emission field strength measurements in the anechoic chamber below 30 MHz



Photograph No.2 Setup for spurious emission field strength measurements in the anechoic chamber in 30 – 1000 MHz range



## Photograph No.3 Setup for spurious emission field strength measurements in the anechoic chamber above 1000 MHz range



Photograph No.4 Setup for substitution ERP measurements in the anechoic chamber



Photograph No.5 Setup for substitution ERP measurements in the anechoic chamber

